Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L4	340	"34"/$.ccls. and (baffle with gas)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 08:25
L5	188	4 and (rotat$3 or rotary)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 08:26
L6	13	4 and (semiconductor or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 08:26
L7	21	34/443,487,510,516.ccls. and @pd>"20021105"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 09:25
L8	36	(semiconductor or wafer) with shower?head	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:10
L9	1626289	(semiconductor or wafer) (shower?head with baffle)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 09:34
L10	1	(semiconductor or wafer) and (shower?head with baffle)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 09:37
L13	444	134/21,30,33,37,153,902.ccls. and @pd>"20021105"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:03
L14	367	13 and (semiconductor or wafer or substrate)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 09:47

L15	225	14 and (rotat$3 or rotary)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 09:47
L16	182	15 and dry$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 09:47
L17	20	438/906.ccls. and @pd>"20021105"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:03
L18	238841	"438"/$.ccls. or "34"/$.ccls. or "134"/$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:03
L19	31	18 and (semiconductor or wafer) and shower?head	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:04
L20	455	(Yuji near2 ono).in. or (ryoichi near2 ohkura).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:09
L21	27	20 and (semiconductor or wafer) and (rotary or rotat$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:10
L22	1	3 and baffle	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/30 10:39